

“Deposition of aminosilane coatings on porous Al₂O₃ microspheres by means of dielectric barrier discharges”. Garzia Trulli M, Claes N, Pype J, Bals S, Baert K, Terryn H, Sardella E, Favia P, Vanhulsel A, Plasma processes and polymers **14**, 1600211 (2017).
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